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PATENT
Atty. Docket No. SYP-060RECN

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Vestal

SERIAL NUMBER: 09/755,951 ART UNIT: 1743

FILING DATE: January 4, 2001 EXAMINER: Soderquist, A.

TITLE: MASS SPECTROMETER SYSTEM AND METHOD FOR
MATRIX-ASSISTED LASER DESORPTION
MEASUREMENTS

Commissioner for Patents
Washington, D.C. 20231

RECEIVED

JAN 14 2002

AMENDMENT AND RESPONSE

TC 1700

Sir:

In response to the Office action mailed from the United States Patent and Trademark Office on July 17, 2001, ("the Office action") Applicant submits this Response. A petition and appropriate fee for a one month extension of time for response up to and including November 19, 2001, are submitted herewith.

AMENDMENT

In the Claims

Please amend claims 75 and 90 to read as follows (A marked-up version of the amended claims is attached at the end of this Amendment and Response).

75. (AMENDED)

A system for obtaining mass data comprising:
a mass spectrometer comprising an ion source chamber, wherein the ion source chamber comprises

a sample receiving stage adapted to support a sample support, and

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02 FC:103
03 FC:102

72.00 OP
336.00 OP